



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

September 2, 2005

Applicant(s): Yuji AKIMOTO et al

For: METHOD FOR MANUFACTURING HIGHLY-CRYSTALLIZED
DOUBLE OXIDE POWDER

Serial No.: 10/611 720 Group: 1755

Confirmation No.: 6093

Filed: July 1, 2003 Examiner: Unknown

Atty. Docket No.: Komatsu Case 287

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**INFORMATION DISCLOSURE STATEMENT**

Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of a Chinese Office Action, Form PTO-1449 and the reference cited thereon.

The undersigned hereby certifies under Rule 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing of this Information Disclosure Statement.

Further consideration is respectfully solicited.

Respectfully submitted,


Terryence F. Chapman

TFC/jp

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Encl: Copy of Chinese Office Action dated June 10, 2005
Form PTO-1449 and cited reference
Postal Card



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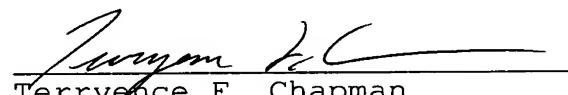
Atty. Docket No.: Komatsu Case 287

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FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 2, 2005.



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Correspondence: Information Disclosure Statement dated September 2, 2005, and all enclosures listed thereon

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INFORMATION
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CITATION

Applicant: Yuji AKIMOTO et al
 Ser.No.: 10/611 720 Filed: July 1, 2003
 Conf. No.: 6093 Atty. Docket No.: Komatsu Case 287
 Group: 1755

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			
	AG			
	AH			
	AI			
	AJ			
	AK			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AL				
	AM				
	AN				
	AO				
	AP				

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	Shuwang, Y., et al., "Study on Ionic Sieve of Titanium Oxide and Lithium Recovery from Brines", <i>Ion Exchange and Absorption</i> , Vol. 8, No. 3, 1992, pages 222-228
	AR	

EXAMINER SIGNATURE

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.